



Inventor Information

Inventor One Given Name:: Masahiro
Family Name:: FURUSAWA
City of Residence:: Suwa-shi
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Two Given Name:: Satoru
Family Name:: MIYASHITA
City of Residence:: Chino-shi
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Three Given Name:: Ichio
Family Name:: YUDASAKA
City of Residence:: Chino-shi
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Four Given Name:: Tatsuya
Family Name:: SHIMODA
City of Residence:: Fujimi-cho
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Five Given Name :: Yasuaki
Family Name:: YOKOYAMA
City of Residence:: Tokyo
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Six Given Name :: Yasuo
Family Name:: MATSUKI
City of Residence:: Tokyo
Country of Residence:: Japan
Citizenship Country:: Japan
Inventor Seven Given Name :: Yasumasa
Family Name:: TAKEUCHI
City of Residence:: Tokyo
Country of Residence:: Japan
Citizenship Country:: Japan

Correspondence Information

Correspondence Customer Number:: 25944

Application Information

Title Line One:: A METHOD FOR FABRICATING A SILICON
Title Line Two:: THIN-FILM
Total Drawing Sheets:: 2
Docket Number:: 111604

Prior Foreign Applications

Foreign Application One:: 2000-402809
Filing Date:: December 28, 2000
Country:: Japan

Priority Claimed:: Yes

Assignee Information

Name of assignee:: SEIKO EPSON CORPORATION
Assignee Address Line One:: 4-1, Nishishinjuku 2-chome
Assignee Address Line Two:: Shinjuku-ku
City:: Tokyo
Country:: Japan
Postal or Zip Code:: 163-0811

Name of assignee:: JSR CORPORATION
Assignee Address Line One:: 11-24, Tsukiji 2-chome, Chuo-ku
City:: Tokyo
Country:: Japan
Postal or Zip Code:: 104-0045